

 APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/601,718		OFGS File No. P/1071-1593 CIP			
		Applicant Gaku KAMITANI					
		Filing Date June 23, 2003		Group Art Unit 2863			
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-						
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
<i>Un</i>	08-015348	01-1996	Japan	 	 	x	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>Un</i>		HP 4284A Precision LCR Meter Instruction Manual, pp. 6-14 to 6-19 (December 1966)					
Examiner	<i>David J. [Signature]</i>		Date Considered <i>9/22/04</i>				
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